

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Jun-ichiro FURIHATA et al.

Prior Group Art Unit: 2812

Application No.: New Rule 53(b) Divisional
of Application No. 09/787,038

Prior Examiner: C. Lattin

Filed: October 23, 2003

Docket No.: 108868.01

For: METHOD OF PRODUCING A BONDED WAFER AND THE BONDED WAFER

INFORMATION DISCLOSURE STATEMENT

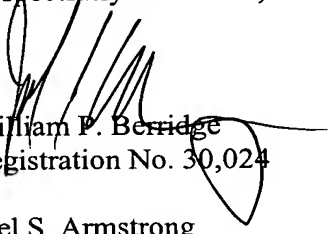
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. The references were cited by or submitted to the Office in parent application No. 09/787,038, filed March 13, 2001, which is relied upon for an earlier filing date under 35 U.S.C. §120. Thus, copies of these references are not attached. 37 CFR §1.98(d).

Respectfully submitted,


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Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 108868.01		APPLICATION NO. New Rule 53(b) Divisional of Application No. 09/787,038	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANT(S) Jun-ichiro FURIHATA et al.			
				FILING DATE October 23, 2003		PRIOR GROUP 2812	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
		US005932048A	8/1999	Furukawa et al.			
		US005899731A	5/1999	Kai et al.			
		US005976983A	11/1999	Miyazaki et al.			
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
		JP A 9-252100	09/22/1997	Japan			
		JP A 5-90545	04/09/1993	Japan			
		JP A 6-349795	12/22/1994	Japan			
		JP A 10-242087	09/11/1998	Japan			
		JP A 6-236867	08/23/1994	Japan			
		JP A 11-162953	06/18/1999	Japan			
		JP A 7-106297	04/21/1995	Japan			
		JP A 10-92777	04/10/1998	Japan			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
EXAMINER					DATE CONSIDERED		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: October 23, 2003